## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)	PATENT APPLICATION
Inventors:	Wei Pan, Yoshi Ono, David Russell Evans, and Sheng Teng Hsu	) ) ) )	Attorney Docket No. SLA0515
Serial No.:	09/819,296	)	Customer No.: 55,286
Filed:	March 27, 2001	)	Group Art Unit 2811
Title:	MULTI-LAYERED BARRIER METAL THIN FILMS FOR Cu INTERCONNECT BY ALCVD	)	Examiner: Vu, Hung K. Confirmation No.: 4061

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **ISSUE FEE RESPONSE**

This paper is responsive to a notice of Allowance mailed on November 4, 2005. Enclosed are:

two copies of the Issue Fee Transmittal form;

a PTO-2038 form, in the amount of \$1709; and,

3 sheets of Replacement drawings.

Respectfully submitted,

Date: 12/16/2005

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